

<b>Notice of References Cited</b>	Application/Control No. 10/029,146	Applicant(s)/Patent Under Reexamination CHOO ET AL.	
	Examiner Mike Qi	Art Unit 2871	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0101398	08-2002	Fujita, Shin	345/90
	B	US-6,466,280	10-2002	Park et al.	349/43
	C	US-6,528,357	03-2003	Dojo et al.	438/151
	D	US-6,522,376	02-2003	Park et al.	349/113
	E	US-6,323,051	11-2001	Shimada, Yoshinori	438/30
	F	US-6,292,237	09-2001	Hebiguchi	349/39
	G	US-6,040,206	03-2000	Kurogane et al	438/149
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.